

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Inventor(s) : Franz LAERMER  
Serial No. : 10/519,724  
Filed : December 28, 2004  
For : DEVICE AND METHOD FOR THE PRODUCTION OF  
CHLORINE TRIFLUORIDE AND SYSTEM FOR  
ETCHING SEMICONDUCTOR SUBSTRATES USING  
THIS DEVICE  
Examiner : Rakesh Dhingra  
Art Unit : 1792  
Confirmation No. : 5180

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

**RESPONSE**

S I R:

This paper is filed in response to the Office Action of June 16, 2008 in connection with the above-captioned application.

**Remarks** begin on page 2 of this paper.